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501.36694CV4



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): S. Shukuri, et al.
Application. No. 10/635,511
Filed: August 7, 2003
For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE HAVING
DEPOSITED LAYER FOR GATE INSULATION
Group: 2814
Examiner: L. Pham

SUPPLEMENTING AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 21, 2004

Sir:

Supplementing the Response filed August 20, 2004, please amend the
above-identified application as listed in the following, and as set forth on the
following pages:

Amendments to the Claims; and

Remarks are included following the amendments.